

Active TI Response Form

Organometallic Compounds Used in Semiconductors

Active TI Form

Date

POC Information

Name

Organization

Title

Email

Phone

Points of Contact or Deposition approach:

Technical Readiness Level

(Ref: https://www.nasa.gov/directorates/heo/scan/engineering/technology/technology_readiness_level/)

Relevant deposition details:

Attachments

Distribution of Information
Provided in this Form

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